

<b>Notice of References Cited</b>	Application/Control No. 10/799,771	Applicant(s)/Patent Under Reexamination CHO ET AL.	
	Examiner Ryan D. Kwiecinski	Art Unit 3635	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,710,074 A	01-1973	Stewart, John L.	219/203
*	B	US-4,593,175 A	06-1986	Bowser et al.	219/203
*	C	US-6,144,017 A	11-2000	Millett et al.	219/522
*	D	US-6,660,968 B1	12-2003	Mottelet et al.	219/203
*	E	US-2005/0024207 A1	02-2005	Schebel et al.	340/545.2
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2001349154 A	12-2001	Japan	ISHIKAWA et al.	E06B 07/28
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.